

LATIN AMERICA Delegation

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Nilton Morimoto obtained his BS in Physics in 1984, MS (1987) and Ph.D. (1995) in Microelectronics at University of São Paulo, Brazil. Since 1982 he has been with the Laboratory of Integrated Systems (LSI) at Polytechnic School - University of São Paulo. He has worked in the microelectronics processes and devices areas. Presently, he is the LSI Administrative Manager and Head of the Integrated Microsystems Divisions and the Thin Films Section of LSI. He published more than 110 papers, mainly on thin films and CVD processes, in different journals and proceedings. His current interests are: CVD thin films deposition processes, materials characterizations technic, smart sensor, IC manufacturing, Micromachining for different applications. Elected President of Brazilian Microelectronics Society (2008/2012 and 2016/2018), and Vice President (2012/2016). Director of the IC Design House of LSI-Tec (since 2007) and of Brazilian National Microelectronics Program (IC Brazil) since 2014.